## Notice of References Cited Application/Control No. 10/781,676 Examiner Tan Ho Applicant(s)/Patent Under Reexamination TAKEI, KEN Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,806,839 B2	10-2004	Lo, Zane	343/725
*	В	US-6,765,538 B2	07-2004	Fang, Chien-Hsing	343/770
*	С	US-6,509,879 B2	01-2003	Cassel, Erland	343/767
*	D	US-6,392,609 B2	05-2002	Nieminen, Otso	343/767
*	Е	US-5,317,324 A	05-1994	Naito et al.	343/700MS
*	F	US-4,197,545	04-1980	Favaloro et al.	343/700MS
	G	US-			
	Н	US-		-	
	ı	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification		
	N							
	0				-			
	Р			2100				
	Ø							
	R							
	s							
	Т							

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	х	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.